

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812 Examiner: Mr. Andre C. Stevenson

In re PATENT APPLICATION of

Applicant(s) : Daigo HOSHINO et al)

Appln: No. : 10/618,661)

Filed : July 15, 2003)

For : METHOD OF MEASURING DEFOCUSING AND METHOD OF OBTAINING CORRECT FOCUSING)

Atty. Dkt. : OKI 360 September 8, 2004

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Attn: BOX Issue Fee

Sir:

Subsequent to issuance of the Notice of Allowance, dated June 25, 2004, kindly amend the above-identified application as specified on the following pages.

FEE ENCLOSED:\$ //
Please charge any further fee to our Deposit Account No. 13-0002

RABIN & BERDO, P.C. 1101 14th Street, N.W. Suite 500 Washington, DC 20005